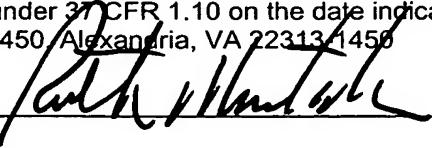


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No. **JG-SU-5196 / 500577.20055**

Applicant(s): **Kazuhiro HARADA, Yoji SUZUKI and Hidenobu ABE**

Application No.:

Filed: **concurrently herewith –January 30, 2004**

For: **METHOD OF MANUFACTURING SILICON SINGLE CRYSTAL AND
SILICON SINGLE CRYSTAL MANUFACTURED BY THE METHOD**

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

SIR:

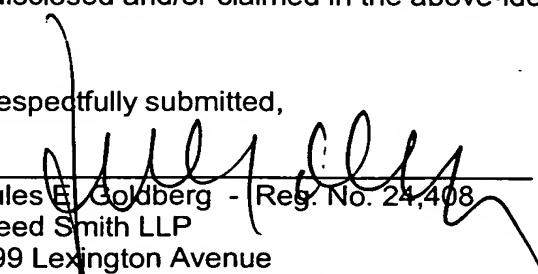
Applicant herewith submits together with the simultaneously patent application this Information Disclosure Statement in accordance with the provisions of 37 C.F.R. §§ 1.97 and 1.98, and hereby make of record the following references:

	Document Number	Date	Name and/or Country	English Translation
AA	6,045,610	04/04/2000	Park, et al.	
AL	11-1393	01/06/1999	JAPAN	English Abstract of Publication No. 2000-199048

Accompanying this Information Disclosure Statement and form PTO-1449 are copies of the AA and JP Publication of AL with English Abstract. Documents AA and AL are mentioned on page 3 of the specification.

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

Respectfully submitted,


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01/30/04
JEG:ram

Tel. (212) 521-5400

Enclosures:

PTO-1449
2 documents
English Abstract

LIST OF PRIOR ART CITED BY APPLICANT
 (Filed on January 30, 2004)

Docket No. **JG-SU-5196 / 500577.20055**Applicant(s): **Kazuhiro HARADA, Yoji SUZUKI and Hidenobu ABE**

Application No.

Group:

Filed: concurrently herewith –January 30, 2004

Examiner:

U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
	AA	6,045,610	04/04/2000	Park, et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub-Class	Translation YES NO
	AL	11-1393	01/06/1999	JAPAN			Abstract only 2000-199048
	AM						
	AN						
	AO						
	AP						
	AQ						
	AR						
	AS						

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AV	
AW	
AX	
AY	
AZ	

Examiner:

Date:

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.